

<b>Notic of References Cited</b>	Application/Control No 10/049,950	Applicant(s)/Patent Under Reexamination SCHMIDT ET AL	
	Examiner Michael C. Zarroli	Art Unit 2839	Page-1 of 1

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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